

Docket No.: 063979-0032

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Yoshiaki HASEGAWA, et al.

Application No.: 10/643,944

Filed: August 20, 2003

For: SEMICONDUCTOR LASER AND PROCESS FOR MANUFACTURING THE SAME

: Customer Number: 20277
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: Confirmation Number: 3843
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: Group Art Unit: 2828
:
: Examiner: Tod Thomas VAN ROY
:

PETITION FOR EXTENSION OF TIME

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

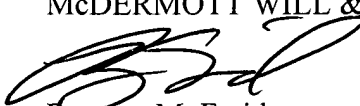
Sir:

It is respectfully requested that the time for response to the Office Action dated November 25, 2005, now due to expire February 25, 2006, be extended for one month(s) and set to expire on March 25, 2006 (Saturday).

Please charge the extension fee of \$120.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP


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Date: March 27, 2006

**Please recognize our Customer No. 20277
as our correspondence address.**

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03/29/2006 HAL111 00000025 500417 10643944
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